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AP/2815

03500.013600.

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MASAAKI IWANE ET AL.

Application No.: 09/346,678

Filed: July 2, 1999

For: CRYSTAL GROWTH PROCESS,
SEMICONDUCTOR DEVICE,
AND ITS PRODUCTION
PROCESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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: Examiner: Jose R. Diaz
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: Group Art Unit: 2815
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: December 17, 2003
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TECHNOLOGY CENTER 2800

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AMENDMENT

Sir:

In response to the Office Action dated September 17, 2003, please amend the
above-identified application as follows.

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450 on

December 17, 2003
(Date of Deposit)

John A. Krause
(Name of Attorney for Applicant)

Signature

December 17, 2003
Date of Signature